

# Robust

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# Introduction

- ▶ Your introduction goes here!
- ▶ Use `itemize` to organize your main points.

## Examples

Some examples of commonly used commands and features are included, to help you get started.

## Periodic boundary conditions

## Bulk modulus

## Bottom to up

- ▶ Generate microstructures that maximize bulk modulus under specified volume fractions as key microstructures.
- ▶ Obtain microstructures for any  $\rho$  through interpolation.
- ▶ Use these as basic units for macroscopic optimization.

# Microstructure interpolation

- ▶ Constructing smooth deformations between two key shapes.
- ▶ Two differences from traditional shape metamorphosis:
  - ▶ The structures have quite similar features.
  - ▶ More focused on smooth variations of physical properties.

## Hashin-Shtrikman bounds

$$K^{\text{HS}}(\rho) = K_0 - \frac{1 - \rho}{\frac{1}{K_0} - \frac{3\rho}{3K_0 + 4G_0}}, \quad (7)$$

$$G^{\text{HS}}(\rho) = G_0 - \frac{1 - \rho}{\frac{1}{G_0} - \frac{6\rho(K_0 + 2G_0)}{5G_0(3K_0 + 4G_0)}}. \quad (8)$$

## Relationship between $E_{ijkl}$ and $\rho$

- ▶ We have several key microstructures.
- ▶ Through interpolation, we have microstructures for each volume fraction, thus obtaining the corresponding  $E_{ijkl}$ .
- ▶ In practice, we directly fit a curve  $E_{ijkl}(\rho)$  based on the data from key microstructures.

$$E_{ijkl}^{\text{fit}}(\rho) = E_{ijkl}^0 - E_{ijkl}^0 \frac{1 - \rho}{1 + a_{ijkl}\rho}.$$



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- ▶ The functional form is inspired by the H-S bounds.
- ▶  $a_{ijkl}$  is obtained through the least squares method.
- ▶ This formula replaces SIMP in the workflow.
- ▶ Predicts data when  $\rho$  is less than the minimum value or greater than the maximum value.

## Combine Bottom to up with Compatibility

- ▶ Use compatibility method when generating key microstructure.